

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE				ATTY. DOCKET NO. NSL-025		SERIAL NO. 10/782,545	
<div style="position: absolute; left: -100px; top: -100px; transform: rotate(-90deg); font-size: 8px;">             OFFICE              MAY 16 2005              PATENT TRADEMARK &amp; COPYRIGHT OFFICE           </div> <b>LIST OF PRIOR ART CITED BY APPLICANT</b> (Use several sheets if necessary)				APPLICANT Martin R. Roscheisen et al.			
				FILING DATE February 19, 2005		GROUP 1762	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
<b>OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
<i>LISA</i>	A	US Patent Application 10/782,163 to Brian M. Sager filed February 19, 2005 entitled "Device based on coated nanoporous structure" (NSL-024)					
<i>HEB</i>	B	US Patent Application 10/782,233 to Karl Pichler filed February 19, 2005 entitled "Roll-to-roll atomic layer deposition method and system" (NSL-026)					
<i>LISA</i>	C	US Patent Application 10/782,017 to Dong Yu et al. filed February 19, 2005 entitled "Solution-based fabrication of photovoltaic cell" (NSL-029)					
<b>EXAMINER</b> <i>[Signature]</i>				<b>DATE CONSIDERED</b> <i>4/24/06</i>			
* <b>EXAMINER:</b> Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							